



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Ravi Iyer

Serial No.: 09/059,865

Filed: April 14, 1998

For: PLANARIZATION USING PLASMA
OXIDIZED AMORPHOUS SILICON

§
§
§
§
§
§
§
§
§
§

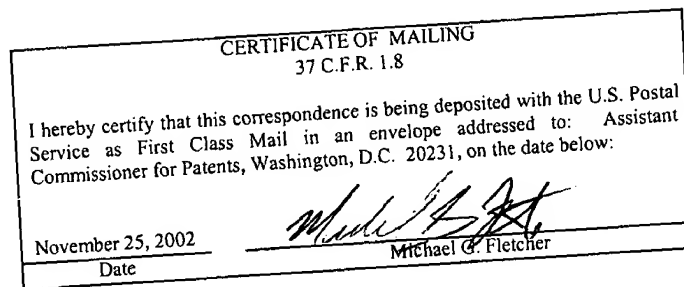
Group Art Unit: 2813

Examiner: Nguyen, T.

Atty Docket: MICS:0015--2/FEB
93-118.02

RECEIVED
DEC -4 2002
TECHNOLOGY CENTER 2800

Assistant Commissioner
for Patents
Washington, D.C. 20231



Sir:

SUPPLEMENT TO REQUEST FOR REHEARING UNDER 37 C.F.R. § 1.197(b)

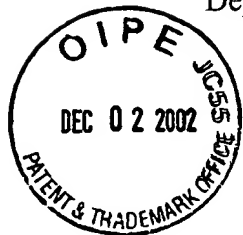
In response to the Decision on Appeal mailed on September 25, 2002, for the above-referenced application, Appellant respectfully requests rehearing of the Board's Decision in view of the remarks set forth below.

In the Request For Rehearing Under 37 C.F.R. § 1.197(b) filed on this date, Appellant failed to address the rejection under obviousness-type double patenting. As previously offered by Appellant, please find attached a properly executed Terminating Disclaimer to obviate the outstanding rejection.

RECEIVED
2003 MAR -3 AM 8:55
BOARD OF PATENT APPEALS
AND INTERFERENCES

The Commissioner is authorized to charge any fees which may be required to

Deposit Account No. 13-3092; Order No. MICS:0015--2/FLE (93-118.02).



Respectfully submitted,

Date: November 25, 2002

Michael G. Fletcher
Reg. No. 32,777
FLETCHER, YODER & VAN SOMEREN
P.O. Box 692289
Houston, TX 77269-2289
(281) 970-4545

RECEIVED
DEC -4 2002
TECHNOLOGY CENTER 2800

RECEIVED
2003 MAR -3 AM 8:55
BOARD OF PATENT APPEALS
AND INTERFERENCES